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S&H Form: (2/01)
DOCKET NO. 1344.1139

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of:

Yuichi KAWAHATA

Serial No: 10/808,579

Group Art Unit: 2613

Confirmation No. 8189

Filed: March 25, 2004

Examiner: Lin, Phyowai

For: CONTROL METHOD OF WAVELENGTH DISPERSION COMPENSATOR, AND
WAVELENGTH DISPERSION COMPENSATOR

COMMUNICATION TO THE EXAMINER

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

The present application claims priority to Japanese Patent Application No. 2003-311083 filed on September 3, 2003. A submission of certified copy of prior foreign applications was filed on March 25, 2004. A copy is enclosed.

This application was allowed on April 21, 2008. The Examiner is requested to acknowledge the claim for priority and receipt of the priority documents, substantially prior to the Issue Fee due date of July 21, 2008. Since this application has been allowed, this matter is somewhat urgent.

Respectfully submitted,

STAAS & HALSEY LLP

By: 
Aaron C. Walker
Registration No. 59,921

Date: 5-20-08

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Yuichi KAWAHATA

Application No.: TBA

Filed: March 25, 2004



COPY

Group Art Unit: TBA

Examiner: TBA

For: CONTROL METHOD OF WAVELENGTH DISPERSION COMPENSATOR, AND
WAVELENGTH DISPERSION COMPENSATOR

SUBMISSION OF CERTIFIED COPY OF PRIOR FOREIGN
APPLICATION IN ACCORDANCE
WITH THE REQUIREMENTS OF 37 C.F.R. § 1.55

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. § 1.55, the applicant submits herewith a certified copy of the following foreign application:

Japanese Patent Application No. 2003-311083

Filed: September 3, 2003

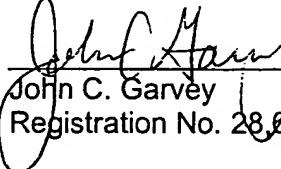
It is respectfully requested that the applicant be given the benefit of the foreign filing date as evidenced by the certified papers attached hereto, in accordance with the requirements of 35 U.S.C. § 119.

Respectfully submitted,

STAAS & HALSEY LLP

Date: 3-25-04

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日本国特許庁
JAPAN PATENT OFFICE

COPY

別紙添付の書類に記載されている事項は下記の出願書類に記載されて
る事項と同一であることを証明する。

This is to certify that the annexed is a true copy of the following application as filed
with this Office.

出願年月日 2003年 9月 3日
Date of Application:

出願番号 特願2003-311083
Application Number:
ST. 10/C] : [JP2003-311083]

願人 富士通株式会社
Applicant(s):

2004年 2月 3日

特許庁長官
Commissioner,
Japan Patent Office

今井康夫